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Substitute for form 1449A/PTO				Complete if Known		
				Application Number	09/916,023	
INFORMATION DISCLOSURE				Filing Date	07-26-2001	
STATEME	STATEMENT BY APPLICANT			First Named Inventor	Christopher C. Hobbs et al.	
				Group Art Unit	2823	
(use as many sheets as necessary)				Examiner Name	Fernando Toledo	
Sheet	1	of	2	Attorney Docket Number	SC11714TP	

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Examiner	Cite No.	Foreign Patent Document			Name of Patentee or	Date of Publication	Pages, Columns, Lines,	T 6
Initials*	1	Office <sup>3</sup>	Number <sup>4</sup> Kind Code <sup>2</sup> (if known)		Applicant of Cited Document	of Cited Document MM-DD-YYYY	Where Relevant Passages or Relevant Figures Appear	
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<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the region of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English Language Translation is attached.



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Sheet	2	of	2	Attorney Docket Number	SC11714TP	

		OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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